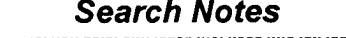


Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/573,139	PURCELL ET AL.
	Examiner	Art Unit
	Qiuwen Mi	1655

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner